

Rev. 9/00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Michael A. Vyvoda et al.
For : WAFER SURFACE THAT FACILITATES
PARTICLE REMOVAL
Serial No. : 09/776,009
Filing Date : February 2, 2001

Hon. Commissioner
for Patents
Washington, D.C. 20231

TRANSMITTAL LETTER FOR
SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

Transmitted herewith is a Supplemental Information
Disclosure Statement in the above-identified application.

This Statement is submitted:

- ☒ [X] within three months of the application filing
date;
- ☐ [] more than three months from the application
filing date but before the mailing date of
the first Office Action on the merits.

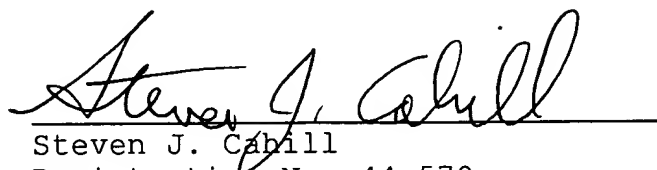
In accordance with 37 C.F.R. § 1.97, submission of
this Statement requires no fee. However, if for any reason
a fee is due, the Commissioner is hereby authorized to
charge payment of any fees required in connection with this
Information Disclosure Statement to Deposit Account

MSI-1

0280
0400
03/07
H2/KDS.
B2 WJW
1-15-01

No. 06-1075. A duplicate copy of this letter is transmitted herewith.

Respectfully submitted,



Steven J. Cahill
Registration No. 44,578
Attorney for Applicants

FISH & NEAVE
Customer No. 1473
1251 Avenue of the Americas
New York, New York 10020-1104
Tel.: (650) 617-4000

Whereby Certify that this
Correspondence is being
Deposited with the U.S.
Postal Service as First
Class Mail in an Envelope
Addressed to: ASSISTANT
COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231, ON

02-21-2001
LILY X. JIANG



Signature of Person Signing



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Michael A. Vyvoda et al.
 For : WAFER SURFACE THAT FACILITATES
 PARTICLE REMOVAL

Serial No. : 09/776,009

Filing Date : February 2, 2001

Hon. Assistant Commissioner
 for Patents
 Washington, D.C. 20231

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with 37 C.F.R. §§ 1.56, 1.97, and 1.98, applicants wish to call the attention of the Examiner to the following documents:

U.S. Patent Application

09/560,626 N. Johan Knall 04/28/2000

This document is listed on the accompanying Form PTO-1449 (submitted in duplicate) and a copy is enclosed herewith.

Consideration of the foregoing in relation to this patent application is respectfully requested.

Respectfully submitted,

Whereby Certify that this
 Correspondence is being
 Deposited with the U.S.
 Postal Service as First
 Class Mail in an Envelope
 Addressed to: ASSISTANT
 COMMISSIONER FOR PATENTS
 WASHINGTON, D.C. 20231, ON

02-21-2000
 LILY X. JIANG

Signature of Person Signing

Steven J. Cahill
 Steven J. Cahill

Reg. No. 44,578

Attorney for Applicants

FISH & NEAVE

1251 Avenue of the Americas

New York, New York 10020-1104

Tel.: (650) 617-4000

c/o